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August 1, 2003

**MAIL STOP PATENT APPLICATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

17760 U.S.P.T.O.  
10/632113  
080103

Re: Application of Maki ITO  
METHOD OF MANUFACTURING A LIQUID-JET HEAD  
Assignee: **SEIKO EPSON CORPORATION**  
Our Ref. Q76707

Dear Sir:

Attached hereto is the application identified above comprising thirteen (13) sheets of the specification (Japanese language), including the claims and abstract and six (6) sheets of drawings. **The requisite U.S. Government Filing Fee, executed Declaration and Power of Attorney, and Assignment will be filed at a later date.**

The Government filing fee is calculated as follows:

Total claims	<u>5</u> - 20	=	<u>          </u>	x	\$18.00	=	<u>          </u>	\$0.00
Independent claims	<u>1</u> - 3	=	<u>          </u>	x	\$84.00	=	<u>          </u>	\$0.00
Base Fee								\$750.00

**TOTAL FEE** \$750.00

Priority is claimed from:

<u>Country</u>	<u>Application No</u>	<u>Filing Date</u>
Japan	2002-225335	August 1, 2002

The priority document will be filed at a later date.

Respectfully submitted,  
SUGHRUE MION, PLLC

Attorneys for Applicant

By: *Darryl Mexic*  
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WASHINGTON OFFICE

**23373**

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